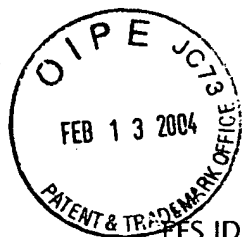


Electronic Filing System (EFS) Data  
Electronic Patent Application Submission  
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EFS ID:

55539

Application ID:

10679844



Title of Invention:

METHODS AND SYSTEMS FOR  
INSPECTING RETICLES USING  
AERIAL IMAGING AT OFF-  
STEPPER WAVELENGTHS

First Named Inventor:

Stan Stokowski

Domestic/Foreign Application:

Domestic Application

Filing Date:

2003-10-06

Effective Receipt Date:

2004-02-13

Submission Type:

Information Disclosure  
Statement

Filing Type:

Confirmation number:

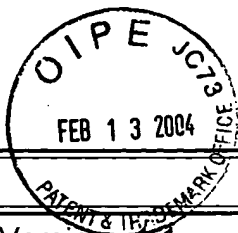
3733

Attorney Docket Number:

5589-04201


Total Fees Authorized:

Digital Certificate Holder: cn=Kevin L. Daffer,ou=Registered Attorneys,ou=Patent and Trademark  
Office,ou=Department of Commerce,o=U.S. Government,c=US  
Certificate Message Digest: 52b2aa9987eff16e05cbbba6f28fdd181e288cc0

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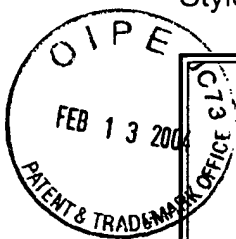
Electronic Version v1.1

Stylesheet Version v1.1.0

<b>Title of Invention</b>	<b>METHODS AND SYSTEMS FOR INSPECTING RETICLES USING AERIAL IMAGING AT OFF-STEPPER WAVELENGTHS</b>									
<p>Application Number: 10/679844 </p> <p>Date: 2003-10-06</p> <p>First Named Applicant: Stan Stokowski</p> <p>Confirmation Number: 3733</p> <p>Attorney Docket Number: 5589-04201</p>										
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<b>Submitted by:</b>	<b>Elec. Sign.</b>	<b>Sign. Capacity</b>								
Kevin L. Daffer Registered Number: 34146	Kevin L. Daffer	Attorney								
<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>5589-04001IDS2-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	5589-04001IDS2-usidst.xml		us-ids.dtd		us-ids.xsl
Documents being submitted	Files									
us-ids	5589-04001IDS2-usidst.xml									
	us-ids.dtd									
	us-ids.xsl									
<b>Comments</b>										

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18  
Stylesheet Version v18.0



Title of  
Invention

METHODS AND SYSTEMS FOR INSPECTING RETICLES  
USING AERIAL IMAGING AT OFF-STEPPER  
WAVELENGTHS

Application Number: 10/679844  
Confirmation Number: 3733  
First Named Applicant: Stan Stokowski  
Attorney Docket Number: 5589-04201  
Search string: ( 6636301 or 6614520 or 6529621 ).pn.



## US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6636301	2003-10-21	Kvamme et al.			
	2	6614520	2003-09-02	Bareket et al.			
	3	6529621	2003-03-04	Glasser et al.			

Signature

Examiner Name	Date